

# ELECTRONIC INFORMATION DISCLOSURE STATEMENT

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## Title of Invention

## TUNED POTENTIAL PEDESTAL FOR MASK ETCH PROCESSING APPARATUS

Application Number : 10/782300



Confirmation Number: 4286

First Named Applicant: PETER SATITPUNWAYCHA

Attorney Docket Number: AMAT/8403

Art Unit: 1763

Examiner:

Search string: ( 4586743 or 4705951 or 4813732 or 4842683 or 4869801 or 5022695 or 5133635 or 5180276 or 5280983 or 5324155 or 5374147 or 5469035 or 5580388 or 5611865 or 5643366 or 5647626 or 5669644 or 5702228 or 5720590 or 5733096 or 5791895 or 5820685 or 6203617 or 6217663 or 6726804 ).pn

## US Patent Documents

**Note: Applicant is not required to submit a paper copy of cited US Patent Documents**

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	4586743	1986-05-06	Alan T. Edwards			
	2	4705951	1987-11-10	Frederick P. Layman			
	3	4813732	1989-03-21	David C. Klem			
	4	4842683	1989-06-27	David Cheng			
	5	4869801	1989-09-26	Dirk Helms			
	6	5022695	1991-06-11	Joe W. Ayers			
	7	5133635	1992-07-28	Cosmas Malin			
	8	5180276	1993-01-19	Ruth A. Hendrickson			
	9	5280983	1994-01-25	Dan Maydan			
	10	5324155	1994-06-28	Dennis L. Goodwin			
	11	5374147	1994-12-20	Tsutomu Hiroki			
	12	5469035	1995-11-21	Robert B. Lowrance			
	13	5580388	1996-12-03	Gary M. Moore			
	14	5611865	1997-03-18	John M. White			
	15	5643366	1997-07-01	Sasson R. Somekh			
	16	5647626	1997-07-15	Chien-Feng Chen			

	17	5669644	1997-09-23	Hideki Kaihotsu			
	18	5702228	1997-12-30	Tadamoto Tamai			
	19	5720590	1998-02-24	Christopher Hofmeister			
	20	5733096	1998-03-31	Matthew J. Van Doren			
	21	5791895	1998-08-11	Hyun-Su Kyung			
	22	5820685	1998-10-13	Kunio Kurihara			
	23	6203617	2001-03-20	Shinya Tanoue			
	24	6217663	2001-04-17	Yasuhiro Inokuchi			
	25	6726804	2004-04-27	Liang-Guo Wang			

**Signature**

Examiner Name	Date